

10/588029

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**OLIFF & BERRIDGE, PLC**

ATTORNEYS AT LAW

**Application Data Sheet**

**Applicant Information**

Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Yuichi  
Family Name:: Shibazaki  
City of Residence:: Kumagaya-shi  
Country of Residence:: Japan

**Correspondence Information**

Correspondence Customer Number:: 25944

**Application Information**

Application Type:: Regular  
Subject Matter:: Utility  
CD-ROM or CD-R:: None  
Title:: STAGE DRIVE METHOD AND STAGE  
UNIT, EXPOSURE APPARATUS, AND  
DEVICE MANUFACTURING METHOD  
Attorney Docket Number:: 127874  
Suggested Drawing Figure:: 1  
Total Drawing Sheets:: 25  
Small Entity:: No

**Representative Information**

Attorneys associated with Customer No. 25944.

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/001076	01/27/2005

<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-025837	02/02/2004	Yes
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-300566	10/14/2004	Yes
<b>Assignee Information</b>			
Assignee Name::		Nikon Corporation	
Street of mailing address::		2-3, Marunouchi 3-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		100-8331	